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PTO/SB/08A (08-00)

Approved for use through 10/31/2002. OMB 0651-0031

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INFORMATION DISCLOSURE STATEMENT BY APPLICANT (use as many sheets as necessary)				Application Number	
				09/900,429	
				Filing Date	
				July 6, 2001	
				First Named Inventor	
		Daiber			
				Group Art Unit	
				2881	
				Examiner Name	
				N/A	
Sheet	1	of	3	Attorney Docket Number	
				NUFO 007	

U.S. PATENT DOCUMENTS						
Examiner Initials ¹	Cite No. ¹	U.S. Patent Documents		Name of Patentee or Applicant of Cited Documents	Date of Publication of Cited Document MM-DD-YYYY	Pages, columns, lines, Where Relevant Passages or Relevant Figures Appear
		Number	Kind Code ² (if known)			
C62		3,967,211		Itzkan et al.	6/29/76	RECEIVED FEB 27 2002 TC 2800 MAIL ROOM
		4,309,671		Malyon	1/5/82	
		4,504,950		AuYeung	3/12/85	
		4,560,246		Cotter	12/24/85	
		4,583,227		Kirkby	4/15/86	
		4,770,047		Arditty et al	9/13/88	
		4,839,614		Hill et al.	6/13/89	
		4,843,233		Jeunhomme	6/27/89	
		4,870,269		Jeunhomme	9/26/89	
		4,932,782		Graindorge et al.	6/12/90	
		4,994,677		Graindorge	2/19/91	
		5,028,395		Sebille et al.	7/2/91	
		5,058,124		Cameron et al.	10/15/91	
		5,103,457		Wallace et al.	4/7/92	
		5,115,677		Martin et al.	5/26/92	
		5,141,316		Lefevre et al.	8/25/92	
		5,172,185		Leuchs et al.	12/15/92	
		5,181,078		Lefevre et al.	1/19/93	
		5,185,643		Vry et al.	2/9/93	
		5,225,930		Land et al.	6/6/93	
		5,270,791		Lefevre et al.	12/14/93	
		5,305,330		Rieder et al.	4/19/94	
		5,319,668		Luecke	6/7/94	
		5,321,717		Adachi et al.	6/14/94	
		5,331,651		Becker et al.	7/19/94	
		5,347,527		Favre et al	9/13/94	
		5,349,439		Graindorge et al.	9/20/94	
	C62		5,349,440		DeGroot	

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FEB 27 2002
TC 2800 MAIL ROOM

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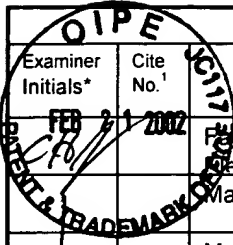
5,373,515	Wakabayashi et al.	12/13/94
5,387,974	Nakatani	2/7/95
5,412,474	Reasenberg et al.	5/2/95
5,420,687	Kachanov	5/30/95
5,428,700	Hall	6/27/95
5,438,579	Eda et al.	8/1/95
5,450,202	Tisue	9/12/95
5,473,625	Hansen et al.	12/5/95
5,543,916	Kachanov	8/6/96
5,583,638	Cutler	12/10/96
5,594,744	Lefevre et al.	1/14/97
5,606,439	Wu	2/25/97
5,631,736	Thiel et al.	5/20/97
5,712,704	Martin et al.	1/27/98
5,719,674	Martin et al.	2/17/98
5,737,109	Goodwin	4/7/98
5,760,391	Narendran	6/2/98
5,802,085	Lefevre et al.	9/1/98
5,825,792	Villeneuve et al.	10/20/98
5,886,785	Lefevre et al.	3/23/99
5,946,331	Amersfoort et al.	8/31/99
5,991,061	Adams et al.	11/23/99
6,061,369	Conradi	5/9/00
6,084,695	Martin et al.	6/4/00
6,108,355	Zorabedian	8/22/00
US 6,192,058	Abeles	2/20/01
US 6,205,159	Sesko et al.	3/20/01
US 6,246,480	O'Brien	6/12/01
US 6,249,364	Martin et al.	6/19/01
US 6,252,718	Lefevre	6/26/01
US 6,282,215	Zorabedian et al.	8/28/01
US 6,304,586	Pease et al.	10/16/01
US 6,330,253	Tuganov et al.	12/11/01
US 6,331,892	Green	12/18/01
USRE 37,044	Wu	2/6/01

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FOREIGN PATENT DOCUMENTS							
Examiner Initials ⁷	Cite No. ¹	Foreign Patent Documents		Name of Patentee or Applicant of Cited Documents	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ⁶
		Office ³	Number ⁴	Kind Code ⁵ (if known)			
CHP			EP0924628		Kessenich et al.	8/11/1998	
CHP			WO 98/44424		Marmor et al.	10/8/1998	

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09/900,429

OTHER PRIOR ART—NON PATENT LITERATURE DOCUMENTS		
Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.
		Favre et al.: 'External-Cavity Semiconductor Laser With 15 nm Continuous Tuning Range', Electronics Letters June 19 1986
		Macleod, H. A. in Thin Film Optical Filters 2 nd Edition, McGraw-Hill, 1989, pgs 244-269
		Mellis et al.: 'Miniature Packaged External-Cavity Semiconductor Laser With 50Ghz Continuous Electrical Tuning Range' Electronics Letters April 22 1988
		Rosenberg, K. P., et al., "Logarithmically Variable Infrared Etalon Filters," SPIE, Vol. 2262/223, pgs. 223-232
		Scobey M. and Stupik P., "Stable Ultra-Narrow Bandpass Filters," SPIE, Vol. 2262, pgs. 37-46
		Siegman A. E., "An Introduction to Lasers and Masers," McGraw-Hill, Inc., 1971
		Takashashi, H., "Temperature Stability of Thin-Film Narrow-Bandpass Filters Produced by Ion-Assisted Deposition Applied Optics Vol 34 No 4 Feb 1 1995
		Yoder, Optical Instrument Structural Design, pp. 612-619
ckg		Zhang, X.X., "An Interference Filter Based External Cavity Laser For Dense Wavelength Division Multiplexing Applications," Corning OCA Corp. pgs 103-108

Examiner Signature		Date Considered	11/21/02
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